

**PATENT APPLICATION**

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Hiroshi SERA et al.

Application No.: 10/630,861

Docket No.: 116741

Filed: July 31, 2003

For: METHOD FOR MANUFACTURING INSULATING RESIN LAYER, SUBSTRATE  
FOR ELECTRO-OPTICAL DEVICES, METHOD FOR MANUFACTURING  
ELECTRO-OPTICAL DEVICE, AND ELECTRO-OPTICAL DEVICE

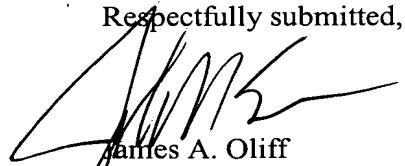
**REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,



James A. Oliff  
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JAO:JSK/kap

Date: May 26, 2004

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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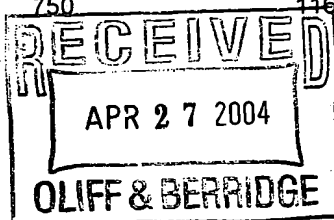
## UNITED STATES PATENT AND TRADEMARK OFFICE

MAY 26 2004

UNITED STATES DEPARTMENT OF COMMERCE  
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APPL NO.	FILING DATE (c) DATE RECEIVED	ARTWORK RECEIVED	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/630,861	07/31/2003		750	116741	10	1	1

25944  
 OLIFF & BERRIDGE, PLC  
 P.O. BOX 19928  
 ALEXANDRIA, VA 22320



CONFIRMATION NO. 9071

## FILING RECEIPT



\*OC0000000 12443622\*

Date Mailed: 04/26/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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 Fujimi - machi

## Assignment For Published Patent Application

SEIKO EPSON CORPORATION, Tokyo, JAPAN;

## Domestic Priority data as claimed by applicant

## Foreign Applications

JAPAN 2002-248984 08/28/2002  
 JAPAN 2003-199929 07/22/2003

If Required, Foreign Filing License Granted: 04/20/2004

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

## Title

Method <sup>for</sup> of manufacturing resin insulating layer, substrate for <sup>electro-</sup> electric <sup>devices</sup> optical apparatus, method <sup>for</sup> of

~~electro- device~~ ~~electro- device~~  
 manufacturing ~~electric optical apparatus~~ and ~~electric optical apparatus~~

## Preliminary Class

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**OLIFF & BERRIDGE, PLC**

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ATTORNEYS AT LAW

**Application Data Sheet****Application Information**

Application Type::	Regular
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	METHOD OF MANUFACTURING RESIN INSULATING LAYER, SUBSTRATE FOR ELECTRIC OPTICAL APPARATUS, METHOD OF MANUFACTURING ELECTRIC OPTICAL APPARATUS, AND ELECTRIC OPTICAL APPARATUS
Attorney Docket Number::	116741
Total Drawing Sheets::	10
Small Entity::	No

**Applicant Information**

Applicant Authority type::	Inventor
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Country of Residence::	Japan

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Family Name::	NAKASHIMA
City of Residence::	Fujimi-machi
Country of Residence::	Japan

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**Correspondence Information**

Correspondence Customer Number:: 25944

<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-248984	08/28/2002	Yes
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-199929	07/22/2003	Yes
<b>Assignee Information</b>			
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Postal or Zip Code of mailing address::		163-0811	